

AF/2814  
JFW



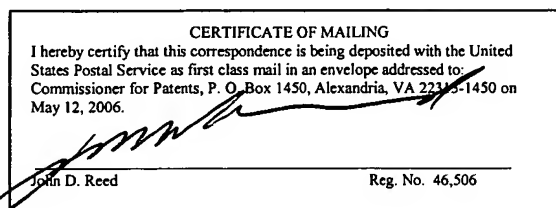
IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Application of

Applicant(s) : Todd Edgar  
Serial No. : 10/044,178  
Filed : January 10, 2002  
Title : SEMICONDUCTOR DEVICE INCORPORATING AN ELECTRICAL  
CONTACT TO AN INTERNAL CONDUCTIVE LAYER AND METHOD  
FOR MAKING THE SAME  
Docket : MIO 0011 N2  
Examiner : Thao Le  
Art Unit : 2814

**MAIL STOP AF**  
Commissioner for Patents  
PO Box 1450  
Alexandria, Virginia 22313-1450

Sir:



RESPONSE UNDER 37 CFR 1.116

This response is being filed in response to an Office Action mailed February 14, 2006, having a reply due date of May 14, 2006. Reconsideration is respectfully requested in light of the amendments and remarks below.

**Amendment to the Claims** begins on page 2.

**Remarks** begin on page 8.